

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

<b>In Re Application of:</b>	Tsuyoshi MATSUDA; Tatsuhiko HIRANO; Junhui OH; Atsunori KAWAMURA; Kenji SAKAI
<b>Application No.:</b>	10/574115
<b>Filed:</b>	September 30, 2004
<b>For:</b>	POLISHING COMPOSITION AND POLISHING METHOD
<b>Examiner:</b>	Michael A. Marcheschi
<b>Group Art Unit:</b>	1793

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Docket No: O11.2I-13210-US01**

**PETITION FOR AN EXTENSION OF TIME UNDER 37 CFR §1.136**

Applicant(s) hereby request a two month extension of time to respond to the Office Action mailed April 10, 2008. Please charge the 2 month extension fee of \$460.00 to our Deposit Account, No. 22-0350.

Respectfully submitted,  
VIDAS, ARRETT & STEINKRAUS, P.A.

Date: September 10, 2008

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